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REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE - 2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Li Docket No.: 2003 P 54309 US

Serial No.: 10/748,995 Art Unit: 2811

Filed: December 30, 2003 Examiner: Donghee Kang

Title: Transistor with Silicon and Carbon Layer in the Channel Region

Mail Stop: AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed July 15, 2005. Please amend the above-referenced application as follows.

O.K to enter Amdt After Final

D-H-C

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Amendment